

10/562158

Docket No.: 4684-030

JC10 Rec'd PCT/PTO <sup>PATENT</sup> 23 DEC 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Kang-Ho AHN : *Confirmation No.* -----  
U.S. Patent Application No. ----- : *Group Art Unit:* -----  
Filed: *herewith* : *Examiner:* -----

For: APPARATUS FOR CONTROLLING FLOW RATE OF GASES USED IN  
SEMICONDUCTOR DEVICE BY DIFFERENTIAL PRESSURE

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,  
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Date: December 23, 2005  
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**INFORMATION DISCLOSURE  
 CITATION IN AN  
 APPLICATION**  
 (PTO-1449)

ATTY. DOCKET NO.  
 4684-030

U.S. APPLICATION NO.  
 Not yet assigned  
**10/562158**

APPLICANT  
 Kang-Ho AHN

FILING DATE  
 herewith

GROUP

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6 152 162	11/28/2000	BALAZY et al			
	6 539 968 B1	04/01/2003	WHITE et al			

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	3 111 914	05/13/1991	JP			abstract	
	8 063 235	03/08/1996	JP			abstract	
	8 152 346	06/11/1996	JP			abstract	

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.